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U.S. UTILITY Patent Application

PATENT NUMBER and
ISSUE DATE

61579

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APPL NUM 10029192	FILING DATE 12/20/2001	CLASS 438	SUBCLASS 5	GAU 1785	EXAMINER Vinh Mathieu
**APPLICANTS: Gotkis Yehiel; Owczarz Aleksander; Kistler Rod. <div style="text-align: right;">1753</div>					
**CONTINUING DATA VERIFIED: <div style="text-align: center;">none km</div>					
** FOREIGN APPLICATIONS VERIFIED: <div style="text-align: center;">none km</div>					
PG-PUB <input type="checkbox"/> DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>			
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no		35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no		ATTORNEY DOCKET NO LAM2P314	
TITLE : Method and apparatus for chemical mechanical planarization <small>U.S. DEPT. OF COMM./PAT. & TM.-PTO-436L (Rev. 12-94)</small>					

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Sheets Drwg.	Figs. Drwg. Print Fig.
<input type="checkbox"/> TERMINAL DISCLAIMER		Application Examiner	
		PREPARED FOR ISSUE	
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